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RESPONSE UNDER 37 CFR 1.416  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2813

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Toshiyuki SHIGARAKI )  
Application No.: 09/851,158 )  
Filed: May 9, 2001 )  
For: SEMICONDUCTOR MANUFACTURING )  
APPARATUS AND METHOD OF )  
MANUFACTURING SEMICONDUCTOR )  
DEVICES )

Examiner: E. Kielen  
Group Art Unit: 2813  
July 15, 2003

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. A copy of the listed document is also enclosed.


Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to

charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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Attorney for Applicant  
Steven E. Warner  
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